

<b>Notice of References Cited</b>	Application/Control No. 10/826,302	Applicant(s)/Patent Under Reexamination LI ET AL.	
	Examiner Cybille Delacroix-Muirheid	Art Unit 1614	Page 1 of 1


**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,730,699	05-2004	Li et al.	514/449
*	B	US-6,515,017	02-2003	Li et al.	514/449
*	C	US-6,441,025	08-2002	Li et al.	514/449
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
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	X	<div style="text-align: center;">  <span style="font-size: 1.5em; margin-left: 100px;">9-28-04</span> </div>

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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